

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#16

Date February 12, 2003

In re the Application of

Sunichi SEKI et al.

Group Art Unit: 2814

Application No.: 09/423,969

Examiner: A. Mai

Filed: November 17, 1999

Docket No.: 107471

For: METHOD OF FORMING THIN FILM PATTERNING SUBSTRATE INCLUDING
FORMATION OF BANKS (AS AMENDED)

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

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Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired December 13, 2002, an extension of time for a period of two months is hereby requested. Attached hereto is our Check No. 138955 in the amount of \$410.00 in payment for:

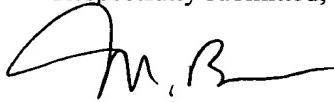
 Extension fee for response within first month pursuant to §1.136(a) (\$110.00)

X Extension fee for response within second month pursuant to §1.136(a) (\$410.00)

 Extension fee for response within third month pursuant to §1.136(a) (\$930.00)

The Director is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,



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